## WHAT IS CLAIMED IS:

- 1. An image sensor to be mounted to a printed circuit board, the image sensor comprising:
- a substrate having an upper surface formed with a plurality of first connection points, and a lower surface formed with a plurality of second connection points, which is electrically connect to the printed circuit board;
  - a photosensitive chip mounted to the upper surface of the substrate;
  - a plurality of wires for electrically connecting the photosensitive chip to the first connection points on the upper surface of the substrate; and
- a frame layer mounted to the upper surface of the substrate to surround the photosensitive chip, and a transparent layer being fixed and encapsulated by the frame layer such that the photosensitive chip may receive optical signals passing through the transparent layer.
- The image sensor according to claim 1, wherein the frame layer is made
   of industrial plastic material by way of injection molding to encapsulate the transparent layer.
  - 3. The image sensor according to claim 1, wherein the transparent layer is a piece of transparent glass.
    - 4. A method for manufacturing an image sensor, comprising the steps of:
- 20 providing a substrate having an upper surface formed with a plurality of first

connection points, and a lower surface formed with a plurality of second connection points, which is electrically connect to the printed circuit board;

mounting a photosensitive chip to the upper surface of the substrate;

providing a plurality of wires for electrically connecting the photosensitive

5 chip to the first connection points on the upper surface of the substrate; and

mounting a frame layer to the upper surface of the substrate so as to surround the photosensitive chip, and a transparent layer is fixed and encapsulated by the frame layer such that the photosensitive chip may receive optical signals passing through the transparent layer.

- 5. The method according to claim 4, wherein the frame layer is made of industrial plastic material by way of injection molding to encapsulate the transparent layer.
  - 6. The method according to claim 4, wherein the transparent layer is a piece of transparent glass.

15